

### for Gravitational Wave Detectors

Niels van Bakel & Martin van Beuzekom Nikihef



# Sensors



# Sensors - Optical



#### ET Webinar 15-7-2020

- Photo diodes (PD, HQE-PD & QPD) -Light power & beam centering
  - -Longitudinal & angular alignment
- Phase cameras - To correct for mirror distortions
- Beam cameras for (pre) alignment of the interferometer and monitoring:
  - -InGaAs pixel detectors, phosphor coated CCD or CMOS
  - -For 1550 nm and 2000 nm?







# Sensors - Displacement, tilt, ...



- Accelerometers
- Displacement sensors (LVDT)
- Inertial rotation sensors (BRMS type)
- Optical levers for mirror tilt
- Inertial motion measurement (Triaxial Nanometrics TC– 120 seismometers)
- Many environmental sensors: temperature, pressure, microphones, magnetometers.... (see Controls)
- Voice–coil actuators
- Piezo-electric stack actuators (PZT)
- Actuators and shadow sensors in a single unit (BOSEM) Laser for thermal compensation

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#### Accelerometer

#### -MEMS sensor with integrated readout

 Photodiodes for LISA -InGaAs QPD with amplifier

- Voice coil mirror driver -3D printing in Aluminum
- Readout electronics for photo-diodes -Discrete and integrated (ASIC) electronics

**Sensors for GW detectors** 

# **R&D** examples













Max-Planck-Institut für Gravitationsphysik ALBERT-EINSTEIN-INSTITUT













- For Newtonian Noise subtraction aiming at **1 ng//Hz** with our **MEMS sensor** at low frequencies
  - -Similar level for vibration monitoring
- Requirements for tilt meters in ET:
  - -For controls around 0.01-0.1 nrad/ /Hz between 0.01-1 Hz;
  - -for NN suppression we look at 1 prad/ /Hz above 1 Hz.

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## Accelerometers









- Quadrant diode with  $\Rightarrow$  2 mm diameter, small gaps (10 - 20  $\mu$ m)
- Input-referred current noise  $\Rightarrow$  < 2 pA/ $\sqrt{Hz}$  (per segment) Hence, low capacitance
- Responsivity  $\Rightarrow$  > 0.7 A/W at 1064 nm  $\Rightarrow$  InGaAs
- Bandwidth ⇒ 2..25 (30) MHz
- Low power dissipation (QPD & TIA)
- Radiation hardness, mechanical & thermal stability .....

# InGaAs Photodiode

**Requires state-of-the-art diode:** large area, low capacitance









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# InGaAs Photodiode

#### 1064 nm



Nik hef





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# InGaAs Photodiode









- Bright Photonics
  - ✓ Design house for Photonic Integrated Circuits
  - ✓ Experience with InP & InGaAs materials



Smart Photonics

✓ Device processing of Indium Phosphide based components



**Sensors for GW detectors** 

### LISA QPD development Fotonica: een nieuwe chipindustrie ziet het licht

Technologie Een strategische lening van 20 miljoen euro bestempelt Smart Photonics tot spil van een nieuwe, veelbelovende Nederlandse chipindustrie.

🖋 Marc Hijink 🕚 30 juni 2020 🝈 Leestijd 2 minuten



https://www.nrc.nl/nieuws/2020/06/30/nieuwechipindustrie-ziet-het-licht-a4004596







# Diodes for ETp & ET

- Diodes for 1550 nm and 2000 nm laser light
  - Shot-noise limited
  - ➡ InGaAs for 1550 nm (commercial)?
  - Extended InGaAs or HgCdTe (MCT) photodiodes for 2000 nm?
- In air-filled enclosure in vacuum

Requires low power electronics

#### **ET** Pathfinder

Description	Quantit
PD 1550 nm	
HQE PD 1550 nm	
QPD 1550 nm	1
PD 2000 nm	
HQE PD 2000 nm	
QPD 2000 nm	1

**ET Table?** 







# Diodes - specs

- Adv Virgo: developed QPD systems with commercial Si-diodes
- LISA: developing InGaAs diodes
- ETp & ET: use expertise for further development in collaboration with industry

λ **[nm]** 

QE

**Material** 

Active area

AC BW

Light power/ seament

	Virgo	Virgo	LISA	ЕТр	ET
	1064	1064	1064	1550	2000
	~55%	>99%	>80%	xxx & >99%	xxx & >99%
	Si	InGaAs	InGaAs	InGaAs	Extende InGaAs MCT 2
а	7 x 7 mm²	mm	2 mm	mm	mm
	1150 MHz	DC?	225 MHz	1 200 MHz	1200 M
	~10 mW		~200 µW	1-100 mW	1-100 m
	Commercial	Custom	Custom	Comm or custom	Custor







- Nikhef developed an In-Air Galvano Gimbaled Mirror for the Virgo experiment.
- To keep a laser beam centered on a quadrant Photo-diode
- Nikhef ordered 20 3D printed aluminium gimbals

https://www.oceanz.eu/over/praktijkcases/3D-printen-in-Aluminium-voor-In-Air-Galvano-Gimbaled-Mirror-Nikhef/

# 3D printing in Aluminum



#### https://youtu.be/mPrhaDXAT9Y







- For example Nikhef Virgo QPD Box
- Phase camera ADC & digital signal processing (see Controls)
- QPD readout LISA diodes discrete and ASIC options
- LVDT readout

# Readout electronics





**Sensors for GW detectors** 

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# Sensors: what we need

- •What we have
- -Big Science pushing the boundaries
- -Exploring novel sensors & techniques (R&D)
- •Challenges
- -Develop instrumentation because not commercially available: low noise, low power, high dynamic range, bandwidth, vacuum, radiation .....
- What we need
- -Collaboration with industry and research institutes on photonics, MEMS fabrication, wafer level packaging, integrated electronics, new materials ....

#### **Ronald Broeke (Bright Photonics): "***The*

development of the diodes for LISA provides us with new knowledge that we will use in other applications in the future. Through collaboration with the NWO institutes Nikhef and SRON, we have explored new grounds in photonics regarding materials, simulation and application development for space"





